

Notice of References Cited	Application/Control No. 10/062,949		Applicant(s)/Patent Under Reexamination UEMURA ET AL.	
	Examiner Eleni A. Shiferaw		Art Unit 2136	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0025272 A1	09-2001	Mori et al.	705/76
*	B	US-2002/0059364 A1	05-2002	COULTHARD et al.	709/203
*	C	US-2002/0095579 A1	07-2002	Yoshiura et al.	713/176
*	D	US-6,647,200 B1	11-2003	Tanaka, Mutsuo	386/46
*	E	US-6,766,454 B1	07-2004	Riggins, Mark D.	713/185
*	F	US-6,572,025 B1	06-2003	Nishikado et al.	235/494
*	G	US-6,317,783 B1	11-2001	Freishtat et al.	709/218
*	H	US-5,935,243 A	08-1999	Hasebe et al.	726/26
*	I	US-5,960,100 A	09-1999	Hargrove, Tom	382/124
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.